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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:      Grivna, Gordon M. et al.  
Serial No.:                      10/773,853  
Filing Date:                    February 9, 2004  
Group Art Unit:                2826  
Examiner:                        Fetsum Abraham  
Title:                              **SEMICONDUCTOR DEVICE HAVING REDUCED  
CAPACITANCE TO SUBSTRATE AND METHOD**

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED  
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Date of Deposit

Semiconductor Components Industries, LLC.

Name of Assignee

*Leyden McChamara*      11-8-04  
SIGNATURE                                      DATE

AMENDMENT

Honorable Commissioner for Patents,  
P.O. Box 1450  
Alexandria, VA 22313-1450

SIR:

In response to the Office Action mailed September 22, 2004,  
please reconsider the above-identified patent application in view  
of the amendments and remarks presented hereinafter.